



EXPEDITED PROCEDURE – EXAMINING GROUP 2818

S/09/471,460

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Thomas A. Figura et al.	Examiner:	Calvin Lee
Serial No.:	09/471,460	Group Art Unit:	2818
Filed:	December 22, 1999	Docket No.:	303.932US4
Title:	USE OF A PLASMA SOURCE TO FORM A LAYER DURING THE FORMATION OF A SEMICONDUCTOR DEVICE		

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed August 22, 2005, please amend the application as follows:

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from November 22, 2005 to December 22, 2005.